

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of)
Yasuhiro SHIMADA et al.) Group Art Unit: 2815
Serial No. 09/804,311) Examiner: E.J. Wojciechowicz
Filed: March 13, 2001)
For: SEMICONDUCTOR DEVICE AND)
METHOD FOR FABRICATING THE SAME) Docket No: 740819-520

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OCT 10 2003

OFFICE OF PETITIONS

INFORMATION DISCLOSURE STATEMENT AND
NOTICE OF REASONS OF REJECTION

Commissioner for Patents
Washington, DC 20231

Sir:


In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Enclosed is a Notice of Reasons of Rejection for a corresponding Japanese patent application together with the references cited therein.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,



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